



THE COMMISSIONER IS AUTHORIZED
TO CHARGE ANY DEFICIENCY IN THE
FEES FOR THIS PAPER TO DEPOSIT
ACCOUNT NO. 23-0975

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of : **Confirmation No. 7670**
Tetsuya MATSUTANI : Docket No. 2003_1039A
Serial No. 10/630,681 : Group Art Unit 2812
Filed July 31, 2003 : Examiner L. Gurley

CONTACT HOLE FORMATION METHOD

RESPONSE

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Pursuant to the requirement contained in the Office Action mailed December 12, 2003, applicant hereby elects invention I, claims 1-10, drawn to a method of making a semiconductor device.

In view of this election, a full examination on the merits of the present application is respectfully requested.

Respectfully submitted,

Tetsuya MATSUTANI

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